

Translated and Published by Japanese Standards Association

JIS Z 3285:2017

Solder paste for micro-joining— Characteristic test methods for solder paste using fine particles

ICS 25.160.50

Reference number: JIS Z 3285:2017 (E)

Z 3285:2017

Date of Establishment: 2017-12-20

Date of Public Notice in Official Gazette: 2017-12-20

Investigated by: Japanese Industrial Standards Committee

Standards Board for ISO area

Technical Committee on Metal and Inorganic

Materials

JIS Z 3285:2017, First English edition published in 2018-07

Translated and published by: Japanese Standards Association Mita MT Building, 3-13-12, Mita, Minato-ku, Tokyo, 108-0073 JAPAN

In the event of any doubts arising as to the contents, the original JIS is to be the final authority.

© JSA 2018

All rights reserved. Unless otherwise specified, no part of this publication may be reproduced or utilized in any form or by any means, electronic or mechanical, including photocopying and microfilm, without permission in writing from the publisher.

Printed in Japan

KK/AT

Contents

		Page
1	Scope	1
2	Normative referen	ices1
3	Terms and definit	ions1
4 4.1 4.2 4.3	Electron microscop Laser diffraction p	ibution measurement 1 pe particle size distribution test 1 particle size distribution test 2 e particle size distribution test 2
5 5.1 5.2 5.3 5.4 5.5	Small sample spir Printability test Slump test Reflow properties	rization of solder paste
Ann	ex A (informative)	Table for recording the particle size distribution measurement results ————————————————————————————————————
Ann	ex B (informative)	Table for recording the small sample spiral viscosity characteristics test results17
Ann	ex C (informative)	Table for recording the printability test results18
Ann	ex D (informative)	Table for recording the slump test results19
Ann	ex E (informative)	Table for recording the reflow properties test results20
Ann	ex F (informative)	Table for recording the high temperature observation test results

Z 3285: 2017

Foreword

This Japanese Industrial Standard has been established by the Minister of Economy, Trade and Industry, through deliberations at the Japanese Industrial Standards Committee in accordance with the Industrial Standardization Law.

This **JIS** document is protected by the Copyright Law.

Attention is drawn to the possibility that some parts of this Standard may conflict with patent rights, applications for a patent after opening to the public or utility model rights. The relevant Minister and the Japanese Industrial Standards Committee are not responsible for identifying any of such patent rights, applications for a patent after opening to the public or utility model rights.

Solder paste for micro-joining— Characteristic test methods for solder paste using fine particles

JIS Z 3285: 2017

1 Scope

This Japanese Industrial Standard specifies the characteristics test methods for solder paste using fine solder particles with a particle size of symbol 7 and symbol 8 specified in **JIS Z 3284-1** (hereafter referred to as solder paste), mainly intended for connection of wiring and components to high-density printed circuit boards with fine wiring (e.g. 60 μm or smaller in minimum conductor width and minimum conductor spacing) used in electronic and communication devices. The test methods specified in this Standard incorporate consideration for the effect of high surface activity of fine solder particles, so that such solder particles can be tested with better precision than when tested using the test methods specified in **JIS Z 3284** series.

2 Normative references

The following standards contain provisions which, through reference in this text, constitute provisions of this Standard. The most recent editions of the standards (including amendments) indicated below shall be applied.

JIS Z 3001-3	Welding and allied processes—Vocabulary—Part 3: Soldering and
	brazing

JIS Z 3284-1 Solder paste—Part 1: Kinds and quality classification

JIS Z 3284-3 Solder paste—Part 3: Test methods for printability, viscosity, slump and tackiness

3 Terms and definitions

For the purpose of this Standard, the terms and definitions given in **JIS Z 3001-3**, **JIS Z 3284-1** and **JIS Z 3284-3**, and the following apply.

3.1 digital microscope

device for displaying a magnified video image on the screen of a personal computer or a monitor

4 Particle size distribution measurement

4.1 Electron microscope particle size distribution test

This method uses a scanning electron microscope (SEM) to measure the particle distribution of a solder powder used for solder paste to confirm that the measured size distribution matches that required for the nominal size of the solder powder.

- a) **Outline of test** The particle size distribution of the solder powder used for solder paste is measured by SEM observation.
- b) **Device and instrument** The following device and instrument shall be used.